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September 26, 2006

MAIL STOP PCT

Commissioner for Patents
 P.O. BOX 1450
 Alexandria, VA 22313-1450

PCT/JP2005/006412
 -filed March 25, 2005

Re: Application of Norifumi FUJIMURA; Ryoma HAYAKAWA; Hiroya
 KITAHATA; Tsuyoshi UEHARA; Takuya YARA
 METHOD AND APPARATUS FOR FORMING OXYNITRIDE FILM AND
 NITRIDE FILM, OXYNITRIDE FILM, NITRIDE FILM, AND SUBSTRATE
Assignee: SEKISUI CHEMICAL CO., LTD.
 Our Ref: Q97348

Dear Sir:

The following documents are submitted herewith in connection with the above application for the purpose of entering the National stage under 35 U.S.C. §371 and in accordance with the Patent Cooperation Treaty:

- ☒ a copy of the executed Declaration and Power of Attorney.
- ☒ an English translation of the International Application.
- ☒ twenty-eight (28) sheets of drawings (Figs. 1-38).
- ☒ an English translation of Article 19 claim amendments.
- ☒ a copy of the executed Assignment and PTO 1595 form.
- ☒ a copy of the ISR.
- ☒ an Information Disclosure Statement.
- ☒ a PTO/SB/08 A & B (modified) listing the ISR references.
- ☒ a copy of each reference cited in the ISR
- ☒ an Notification Concerning Submission or Transmittal of Priority Document.

In addition to the documents submitted herewith, it is assumed that copies of the International Application, the International Search Report and cited references, the International Preliminary Examination Report, and any Articles 19 and 34 amendments as required by §371(c) will be supplied directly by the International Bureau, but if further copies are needed, the undersigned will undertake to provide them upon request.

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